

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S3	123	air adj gap near semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 10:19
S4	2	("6946382").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	OFF	2006/11/16 14:21
S5	2	("6888249").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	OFF	2006/11/16 14:25
S6	5525	430/311	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/16 16:53
S8	994935	photoresist or resist or photosensitive	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 10:18
S14	4481134	air near bridge or pocket or space or gap	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 10:48

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S15	1802	S14 near S8	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 12:49
S16	994935	photoresist or resist or photosensitive	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 12:49
S17	4481003	air adj bridge or pocket or space or gap	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/21 12:26
S18	1801	S17 near S16	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/17 12:49
S19	577	air adj gap near dielectric	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/22 09:12
S20	6	air adj gap near metal adj line	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2006/11/21 12:27